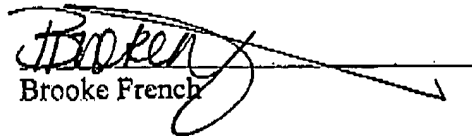


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Date: November 18, 2005
Brooke FrenchIn re application of: **Chen, et al**Confirmation No.: **8561**U.S. Serial Number: **10/733,721**Art Unit: **2826**Filing Date: **December 11, 2003**Examiner: **Pert, Evan T.**Our Reference Number: **250914-1010**Title: **Method of Forming Poly-Silicon Thin Film Transistors****Response to Restriction/Election Requirement****Total Pages Transmitted (including cover sheet) - 7**

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Chen, et al

Serial No.: 10/733,721

Filed: December 11, 2003

Confirmation No. 8561

Group Art Unit: 2826

Examiner: Pert, Evan T.

Docket No. 250914-1010

For: METHOD OF FORMING POLY-SILICON THIN FILM TRANSISTORS

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November 18, 2005
Date


Brooke FrenchAMENDMENT AND RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Mail Stop – Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed on October 20, 2005, has been carefully considered. In response thereto, Applicant hereby submits the following amendments and remarks.